



Atty. Docket No. KIK01 P-322A

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March 2, 2005  
Date

Melanie S. Jernberg  
Melanie S. Jernberg

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 2863  
Examiner : Xiuqin Sun  
Applicant : Kenichiro Kobayashi et al.  
Appln. No. : 10/737,336  
Filing Date : December 16, 2003  
Confirmation No. : 6152  
For : METHOD AND APPARATUS FOR DIRECT IMAGE PICK-  
UP OF GRANULAR SPECK PATTERN GENERATED BY  
REFLECTING LIGHT OF LASER BEAM

Mail Stop Petitions  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

RENEWED PETITION UNDER 37 C.F.R. §1.55(c)

Applicants' Petition to Accept an Unintentionally Delayed Claim for Priority filed on December 30, 2004 was dismissed as the claim of foreign priority was not included in either an Application Data Sheet or on the oath or declaration. Applicants' therefore submit the enclosed Application Data Sheet which identifies the claim of foreign priority. A copy of the Petition filed December 30, 2004 is also enclosed.

The Decision also indicates that a certified copy of Japanese Application Serial No. 2000-166833 had not been submitted, however, Applicants indicated in the Claim of Priority filed on December 30, 2004 that a certified copy of the Japanese application was submitted in the parent of the present application.

Applicants therefore respectfully submit that the Petition Under 37 C.F.R. §1.55(c) to Accept Unintentionally Delayed Priority Claim filed on December 30, 2004 should be granted.

Applicant : Kenichiro Kobayashi et al.  
Appln. No. : 10/737,336  
Page : 2

If there is any fee due in connection with the filing of this document, please charge the fee to our Deposit Account No. 16-2463.

Respectfully submitted,  
**KENICHIRO KOBAYASHI ET AL.**  
By: Price, Heneveld, Cooper,  
DeWitt & Litton, LLP

112105  
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**APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: Kenichiro Kobayashi  
Citizenship: Japan  
Residence: 3-19-10 Asahimachi, Machida-shi, Tokyo-to, Japan

Second applicant: Hiroyuki Konno  
Citizenship: Japan  
Residence: 1206, 1-4-1 Shiroyama, Odawara-shi, Kanagawa-ken, Japan

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Marcus P. Dolce/Price, Heneveld et al.

Customer No.: 000,277

### **3. Application information**

Title of Invention: METHOD AND APPARATUS FOR DIRECT IMAGE PICK-UP OF GRANULAR SPECK PATTERN GENERATED BY REFLECTING LIGHT OF LASER BEAM

Docket number assigned to this application: KIK01 P-322A

Suggested Classification: Class: 702

Subclass: 127

Technology Center to which subject matter is assigned: 2860

Total number of drawing sheets: 2

Type of application: Utility

#### Secrecy order under § 5.2:

This application does not include subject matter of an application which is under a secrecy order pursuant to § 5.2.

### **4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Marcus P. Dolce/Price, Heneveld et al.

Customer No.: 000,277

### **5. Domestic Priority information**

Domestic priority for this application is claimed as follows:

35 U.S.C. § 119(e): Application No.: 09/838,905

Filed: April 20, 2001

Status: Patent No. 6,847,910

Relationship: continuation

### **6. Foreign priority information**

Foreign priority is claimed for this application as follows:

Country: Japan

Application No.: 2000-166833

Filing Date: April 26, 2000

## 7. Assignee information

The assignee of this application is:

Kabushiki Kaisha Toyoseikiseisakusho  
5-15-4 Takinogawa Kita-ku, Tokyo-to, Japan

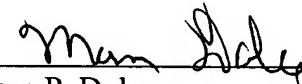
Respectfully submitted,

KENICHIRO KOBAYASHI ET AL.

By: Price, Heneveld, Cooper,  
DeWitt & Litton, LLP

3/21/05

Date



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